

Computational mechanics and stochastic simulation of random polycrystals

N. Venkovic
nvenkov1@jhu.edu

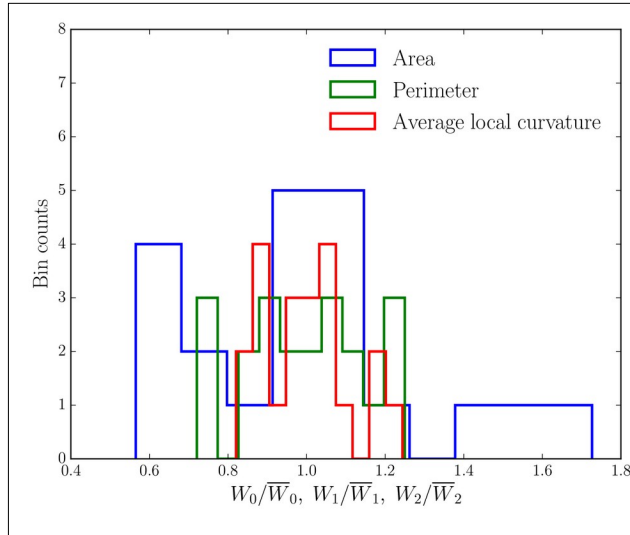


Graduate Board Oral Exam
December 11, 2017

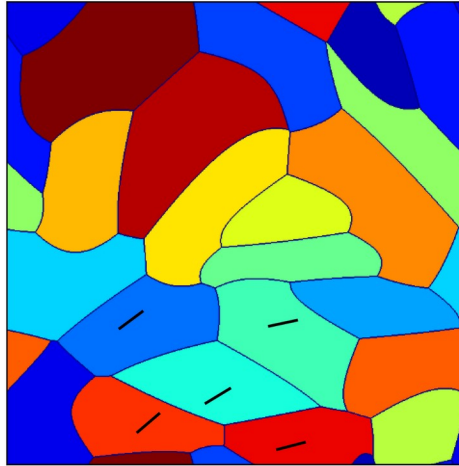
Motivation

Different morphologies lead to different mechanical behaviors.

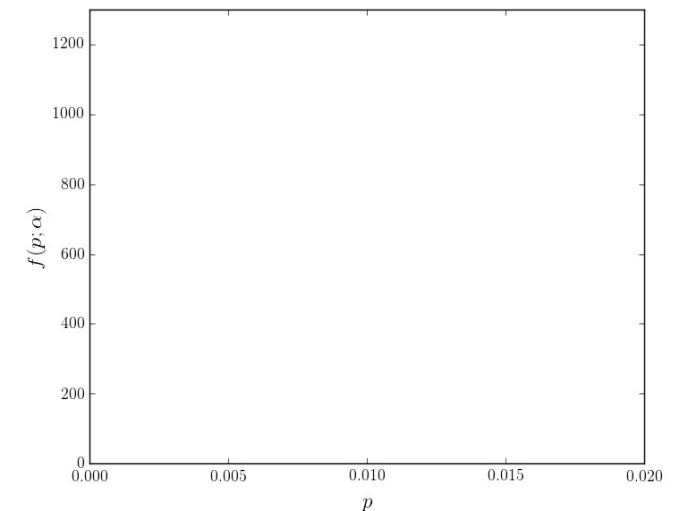
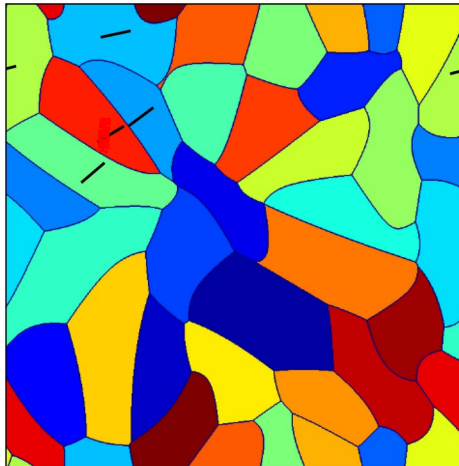
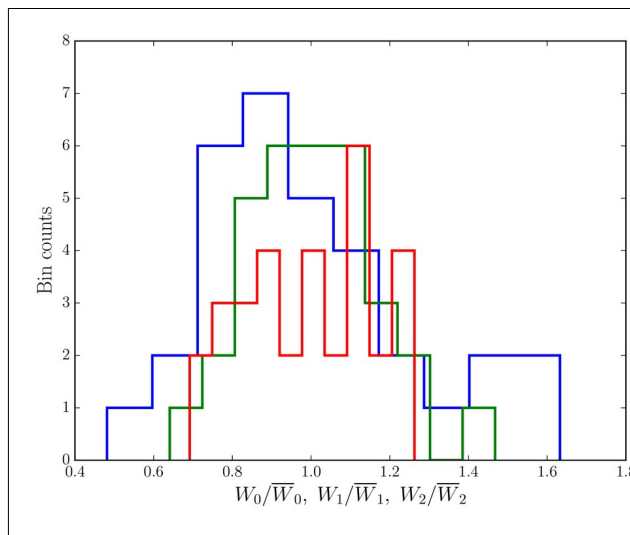
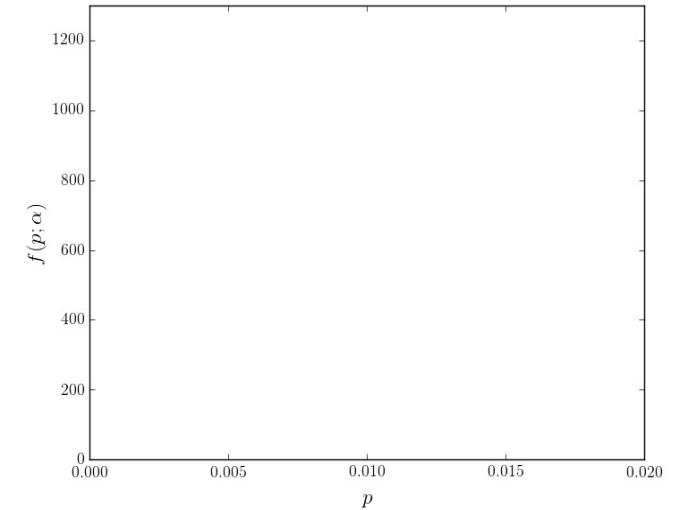
Morphological statistics
of single grains



Periodic viscoplastic polycrystal
subjected to $\bar{\varepsilon}(t) \propto t \underline{e}_1 \otimes \underline{e}_1$



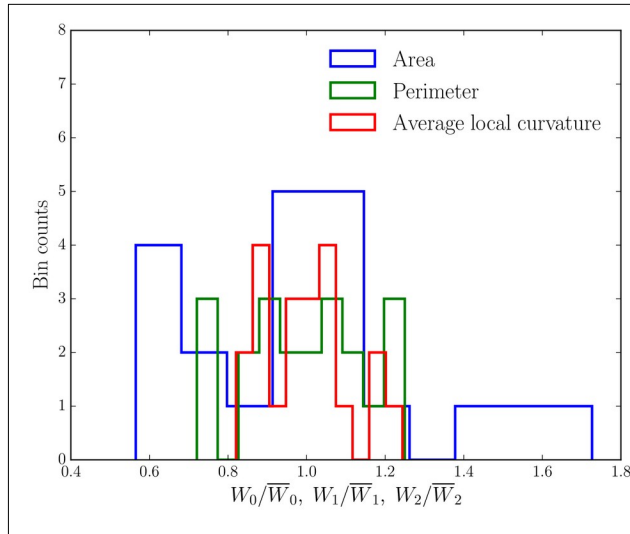
In-grain equivalent
plastic strain densities



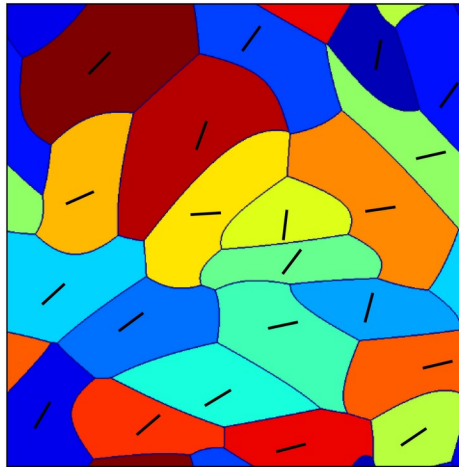
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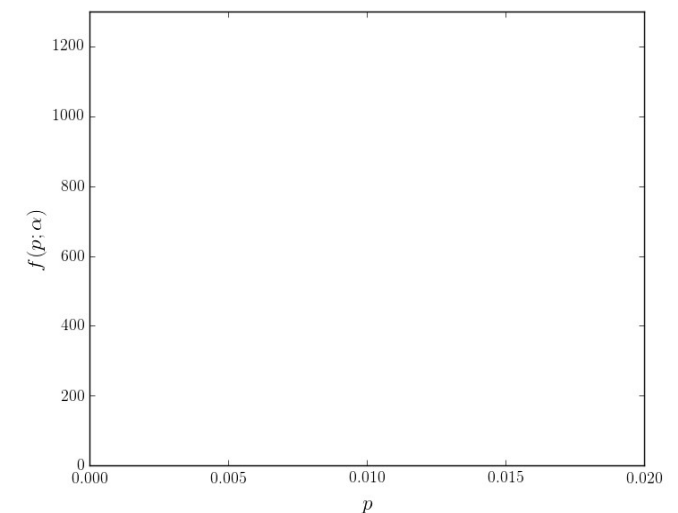
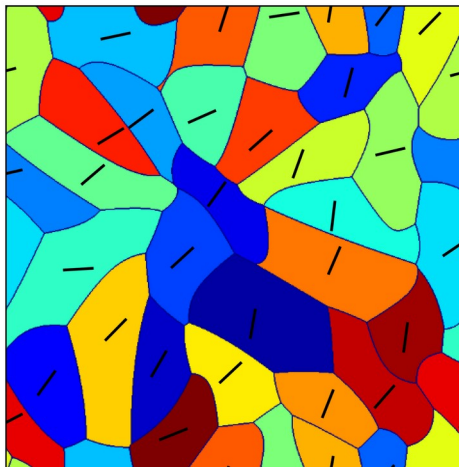
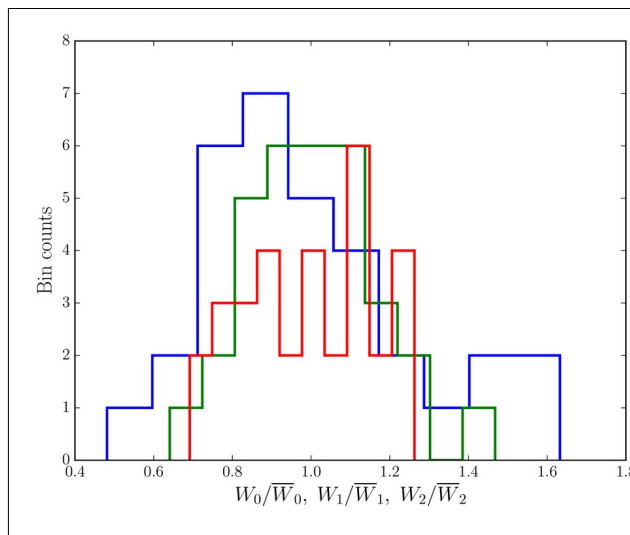
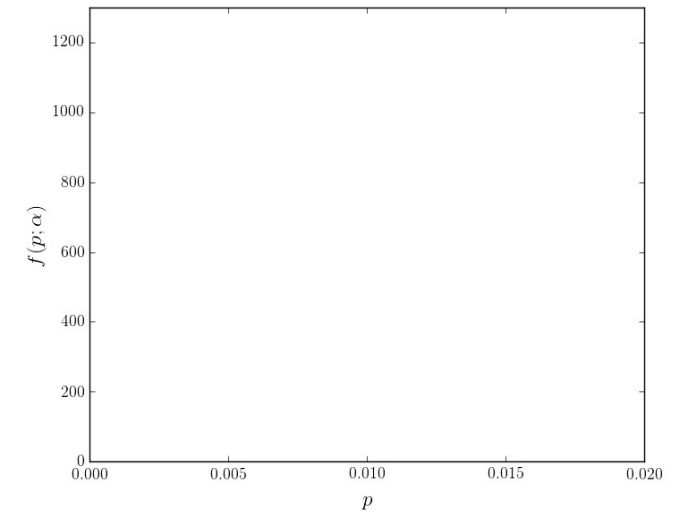
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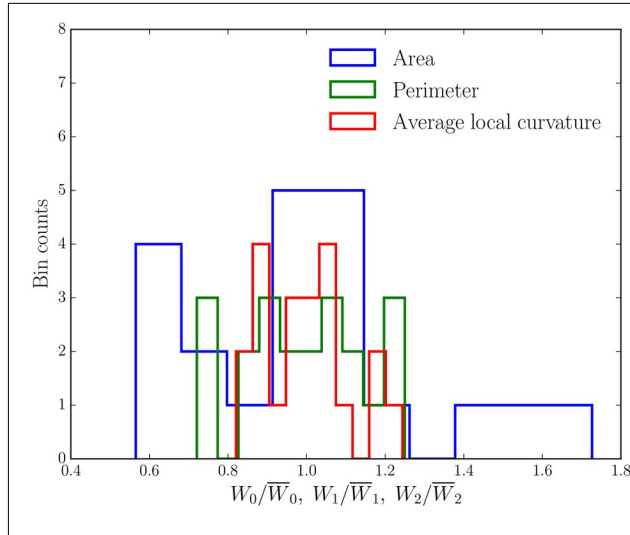
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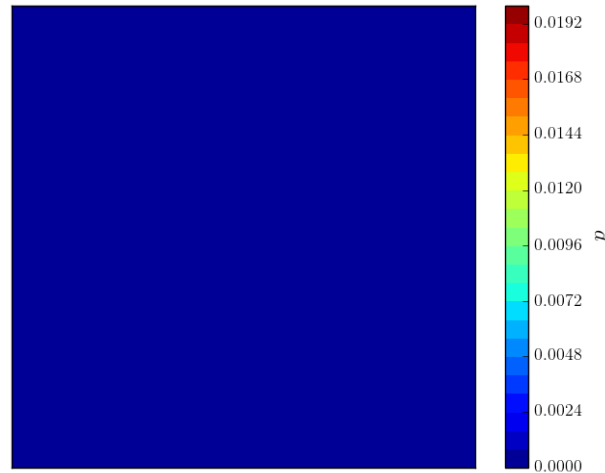
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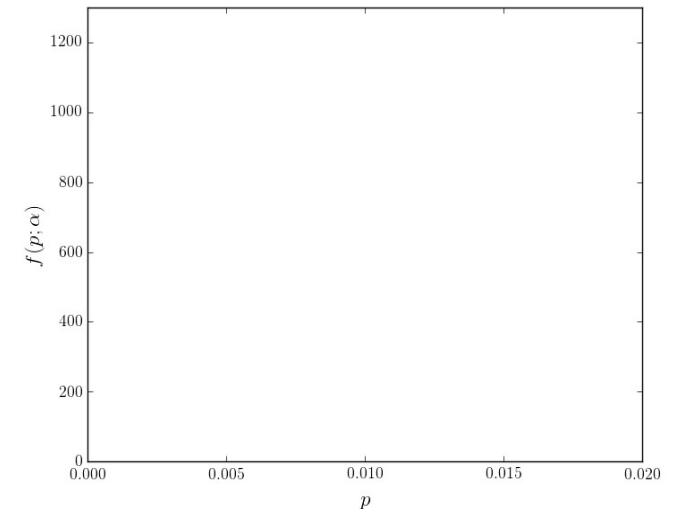
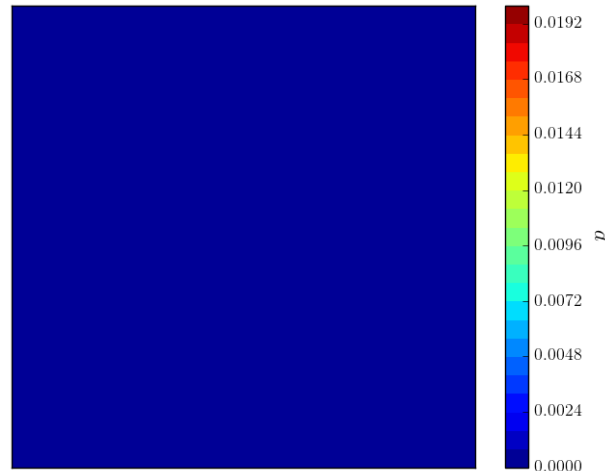
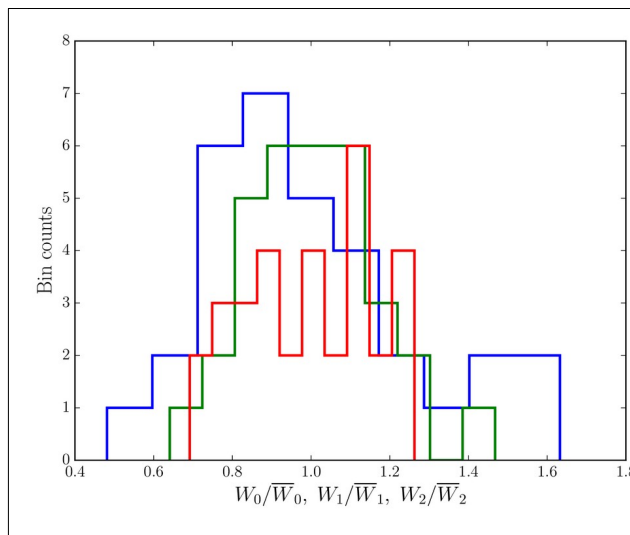
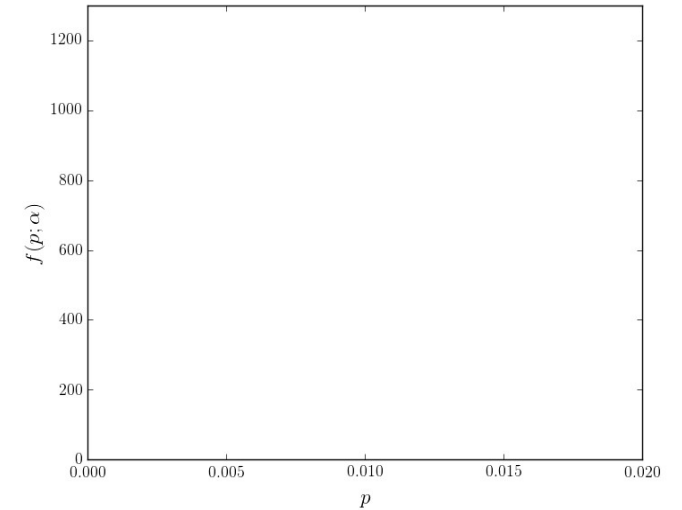
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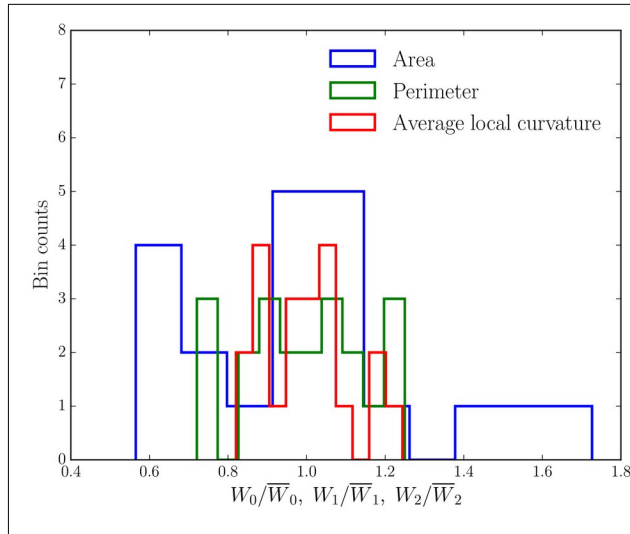
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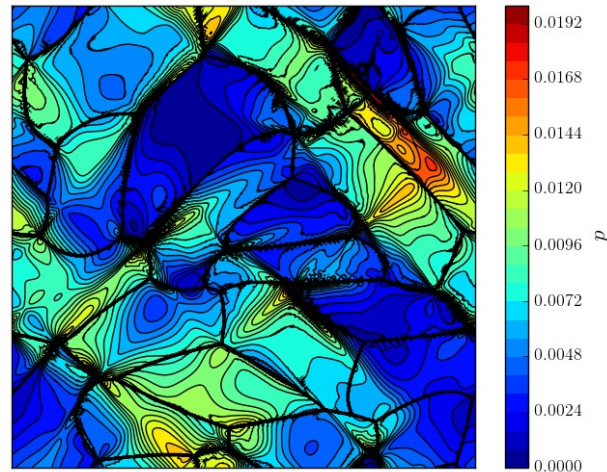
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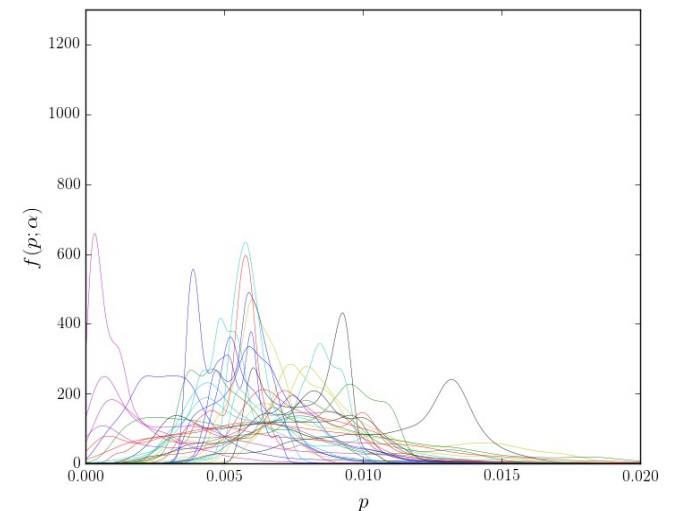
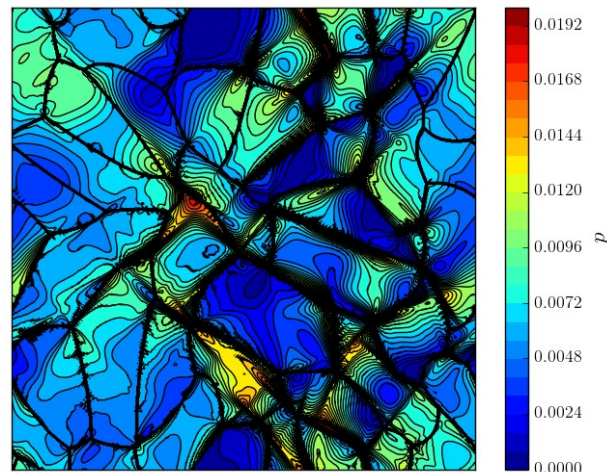
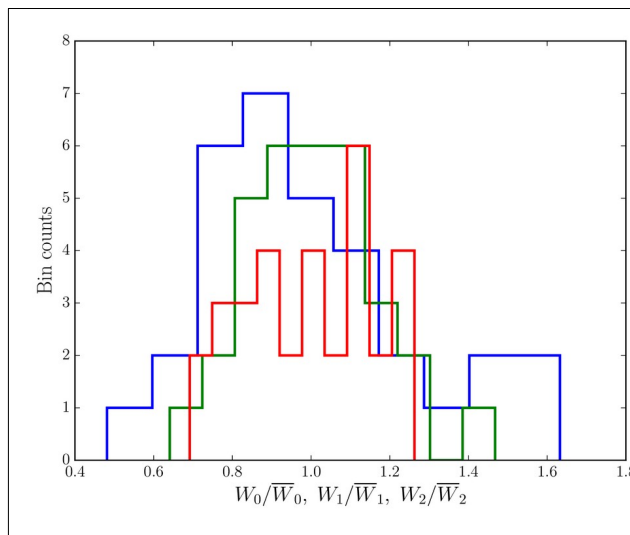
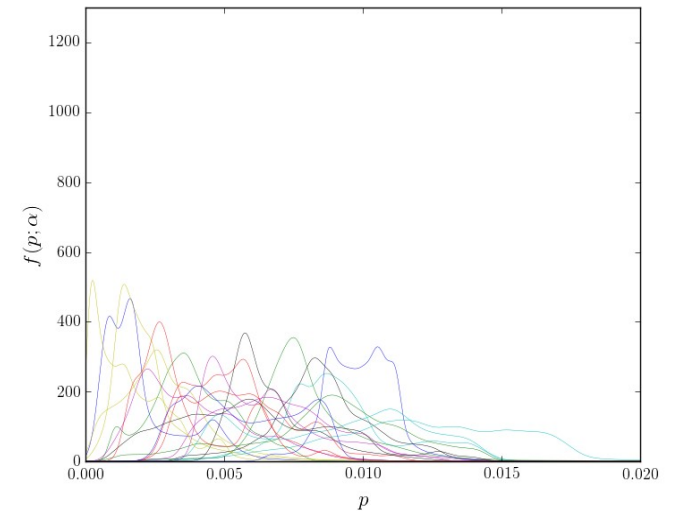
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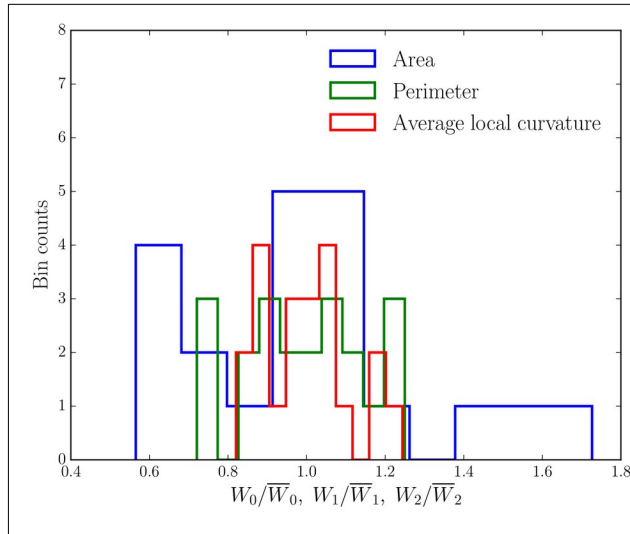
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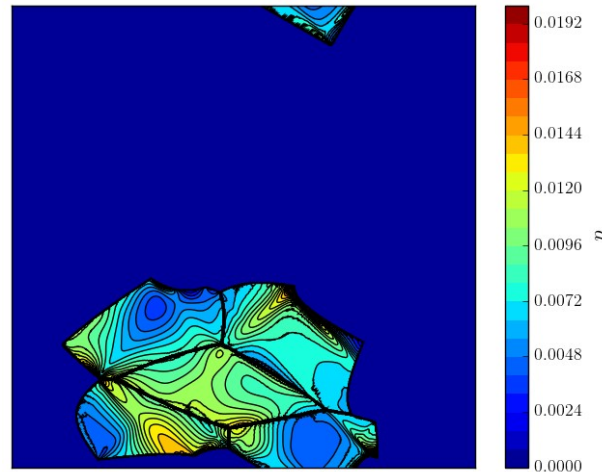
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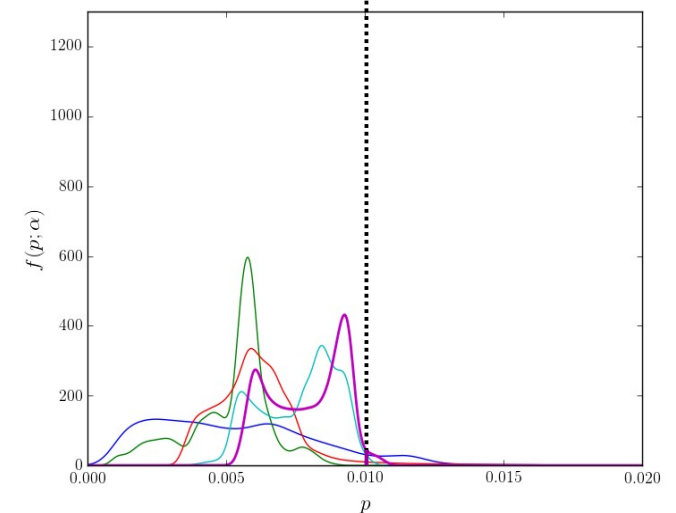
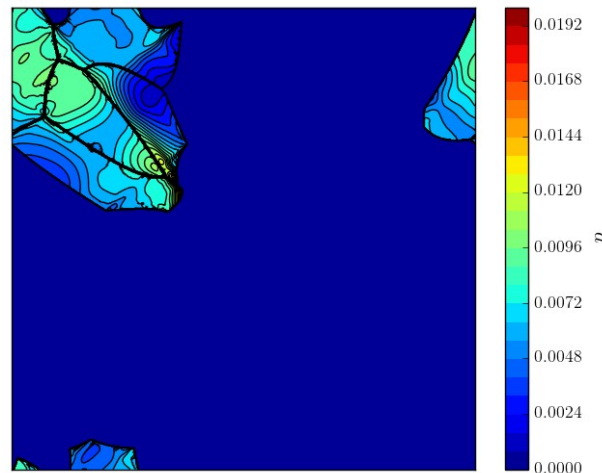
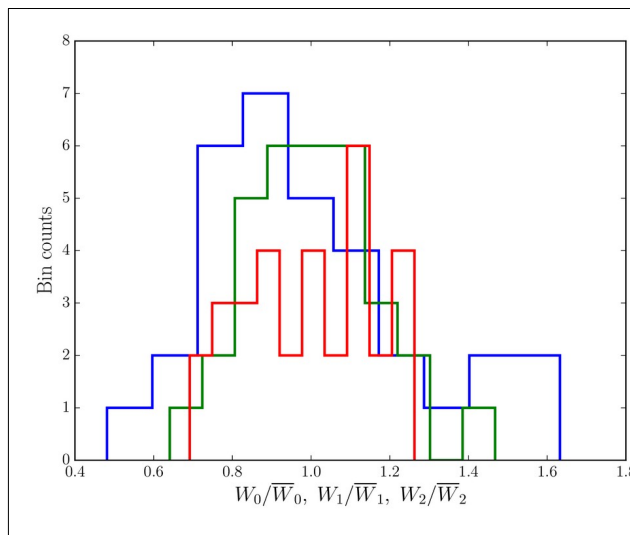
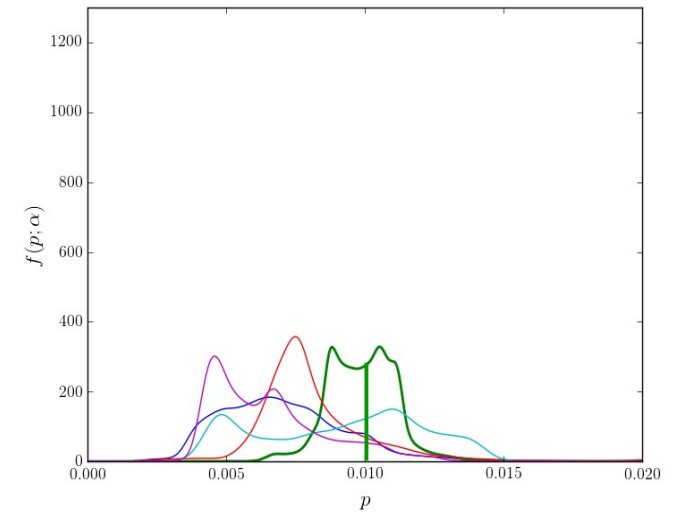
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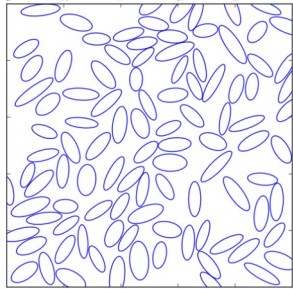


Outline of methodology

Part I. ~80% completed

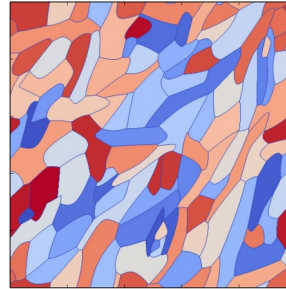
Development of microstructure models & Characterization of morphological anisotropy

Technical objective: Reduce algorithmic complexity



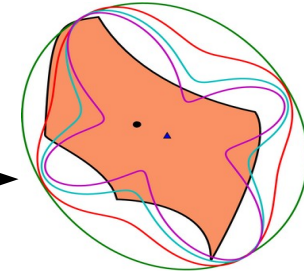
Parametric representation

Numerical resolution



Digital microstructure

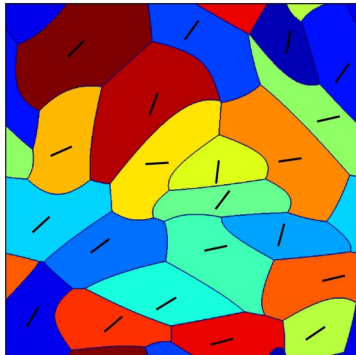
Grain shape characterization



Part II. ~40% completed

Simulation of mechanical behaviors

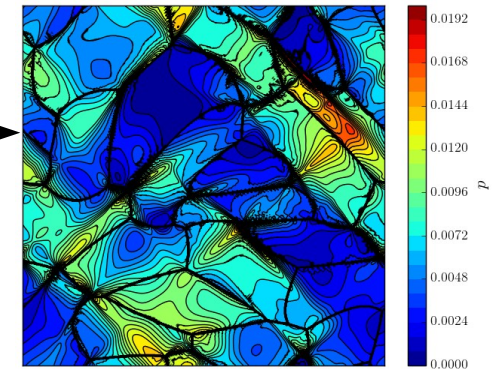
Technical objective: Reduce algorithmic complexity



Construct approximation scheme specific for polycrystalline microstructures

$$\{\bar{\varepsilon}\} = [\Delta \mathbb{M}]\{\tau\} + [\Gamma]\{\tau\}$$

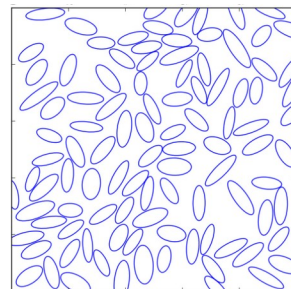
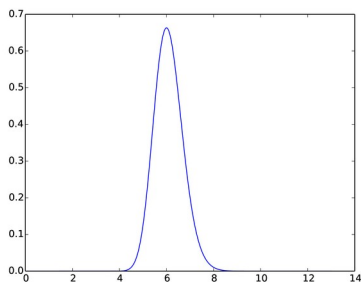
System size scaling with number of grains



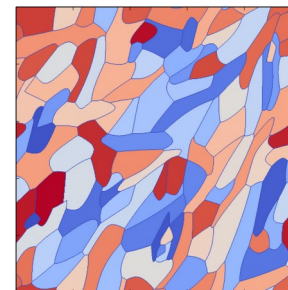
Part III. ~10% completed

Simulation of random microstructures

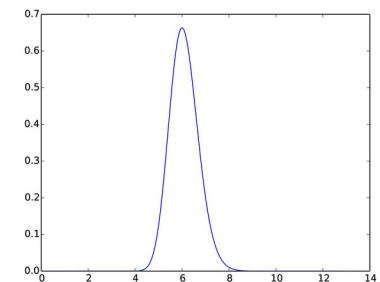
Technical objective: Identify and calibrate marked point processes (MPP)



Part I



Part I



Part I. Parametric representation

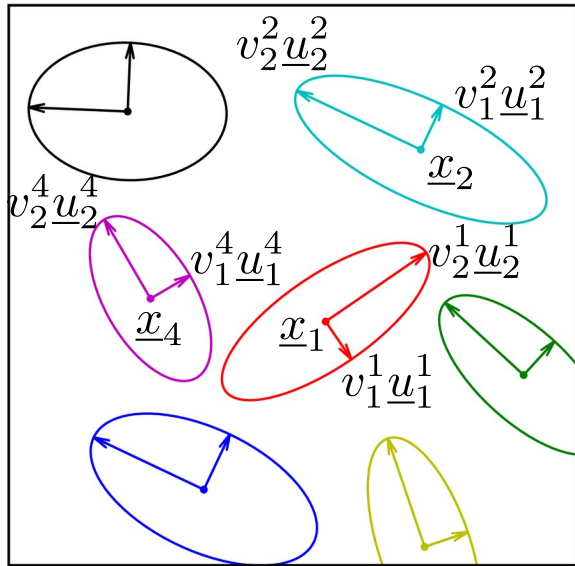
Consider a pattern of n_α marked points

$$\Xi = \{(\underline{x}_\alpha, \mathbf{Z}_\alpha) \mid 1 \leq \alpha \leq n_\alpha, \mathbf{Z}_\alpha \succ 0\}$$

The underlying microstructure $\text{Tess}(\Xi)$ is a partition of space into n_α cells (or grains)

$$\Omega_\alpha = \{\underline{x} \mid \underset{\gamma}{\operatorname{argmin}} (\underline{x} - \underline{x}_\gamma) \cdot \mathbf{Z}_\gamma \cdot (\underline{x} - \underline{x}_\gamma) = \alpha\}$$

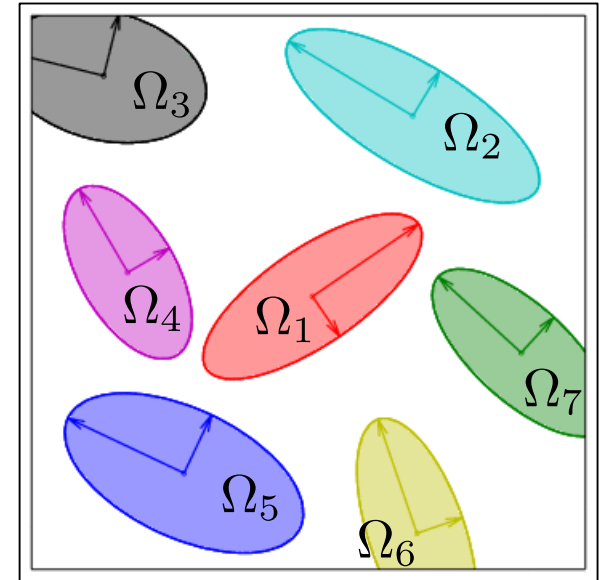
Marked point pattern (MPP)



$$\mathbf{Z}_\alpha = \frac{\underline{u}_1^\alpha \otimes \underline{u}_1^\alpha}{(v_1^\alpha)^2} + \frac{\underline{u}_2^\alpha \otimes \underline{u}_2^\alpha}{(v_2^\alpha)^2}$$

Numerical
Resolution

Underlying microstructure



Part I. Parametric representation

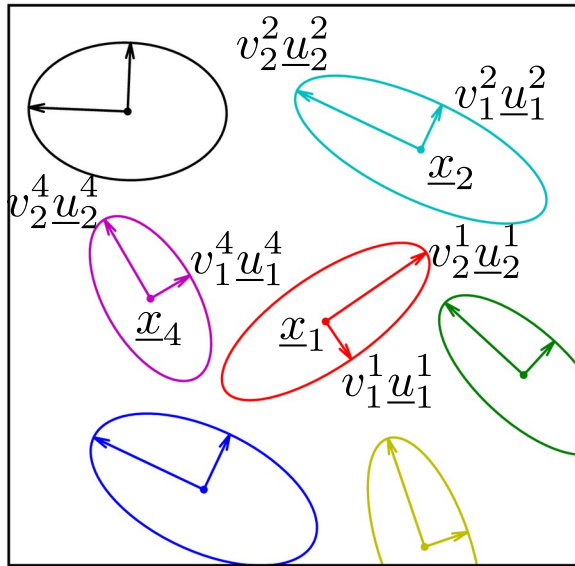
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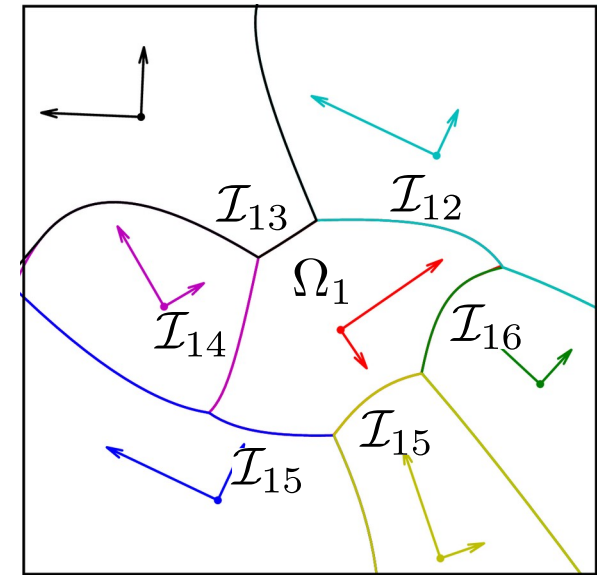
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Numerical
Resolution

Underlying microstructure



Every cell Ω_α has a boundary $\partial\Omega_\alpha$ partitioned into common curves $\mathcal{I}_{\alpha\gamma}$ shared with neighbors its Ω_γ .

Part I. Morphological characterization

Single grains are characterized using Minkowski tensors:

Measures of mass distribution:

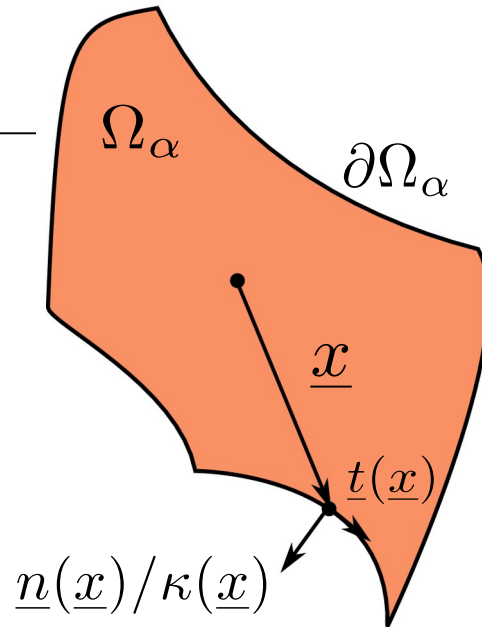
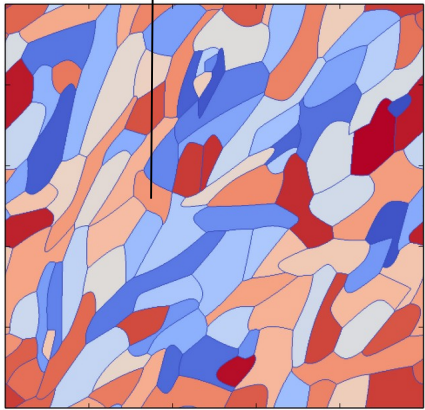
$$\mathcal{W}_0^{r,0} = \int_{\Omega_\alpha} \underline{x}^{\otimes r} dV$$

Measures of surface distribution:

$$\mathcal{W}_1^{r,s} = \int_{\partial\Omega_\alpha} \underline{x}^{\otimes r} \odot [\underline{n}(\underline{x})]^{\otimes s} dS$$

Curvature-weighted measures of surface distribution:

$$\mathcal{W}_2^{r,s} = \int_{\partial\Omega_\alpha} \kappa(\underline{x}) \underline{x}^{\otimes r} \odot [\underline{n}(\underline{x})]^{\otimes s} dS$$

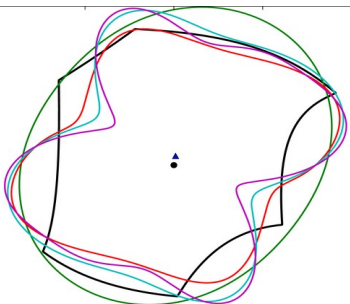


$\underline{n}(\underline{x})/\kappa(\underline{x})$

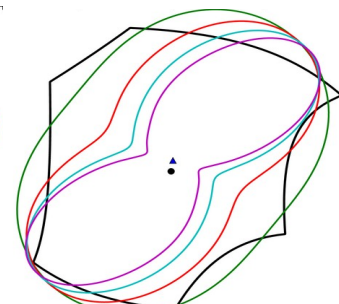
Examples of projection up to order 8

— : $r + s = 2$
— : $r + s = 6$
— : $r + s = 4$
— : $r + s = 8$

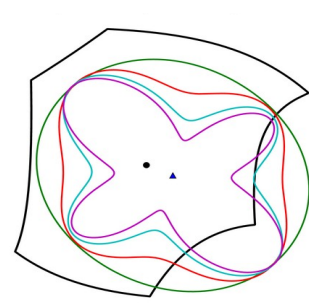
— : $r + s = 3$
— : $r + s = 7$
— : $r + s = 5$
— : $r + s = 9$



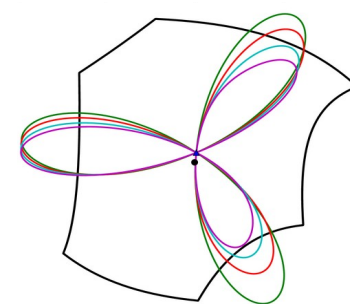
$\mathcal{W}_1^{0,s}$



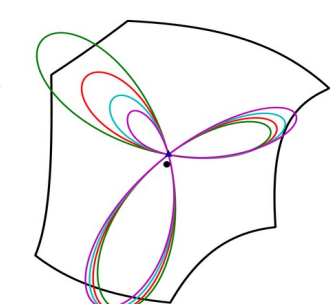
$\mathcal{W}_1^{r,0}$



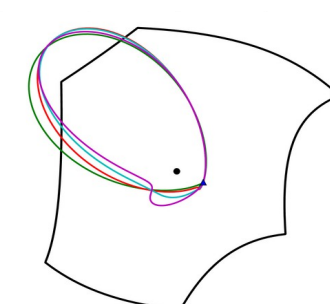
$\mathcal{W}_2^{r,0}$



$\mathcal{W}_1^{0,s}$



$\mathcal{W}_1^{r,0}$



$\mathcal{W}_2^{r,0}$

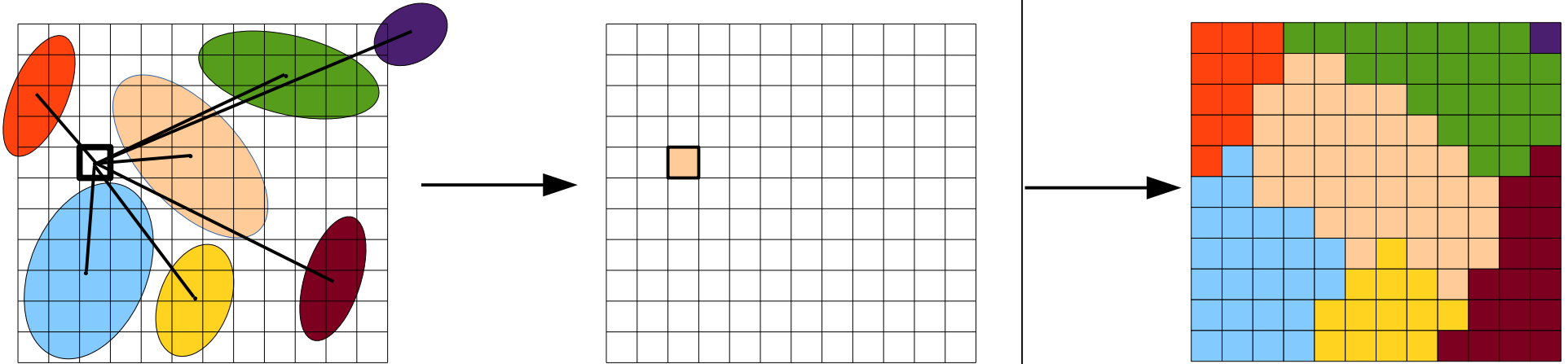
Part I. Numerical resolution – naive approach

1) Discretize the domain into n pixels

2) Proceed as follows pixel-by-pixel

Compute contact times,

attribute pixel,



Resulting algorithm has complexity $O(n)$. How large need n be?

Poor boundary resolution

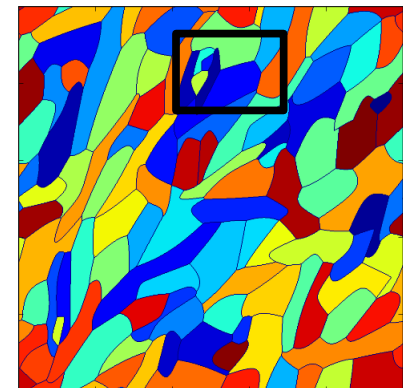
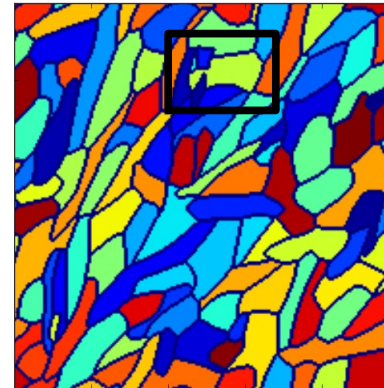
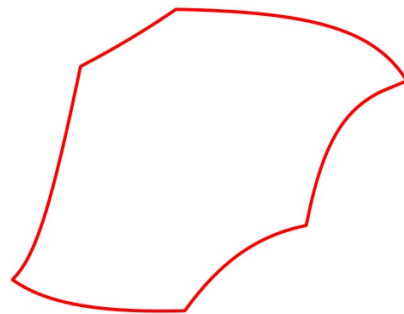
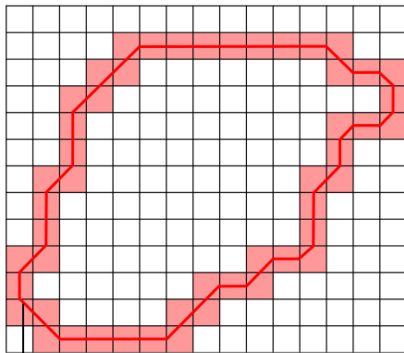
Mislabeling

Small n

Actual boundary

Small n

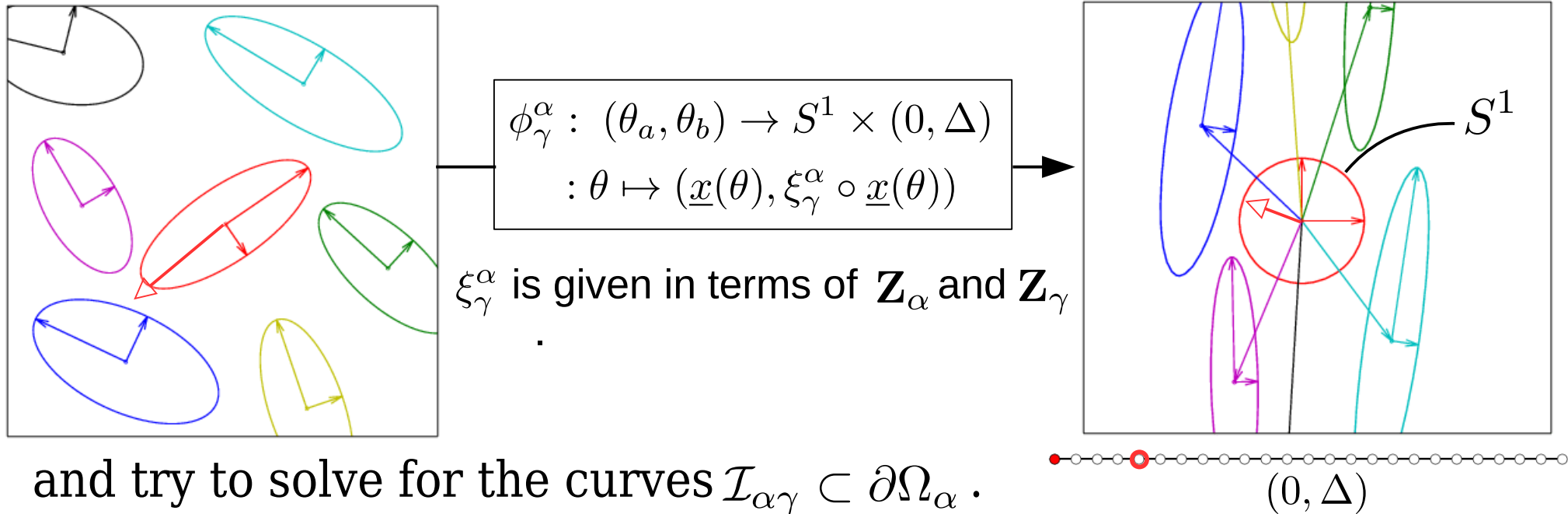
Large n



obtained by Marching squares

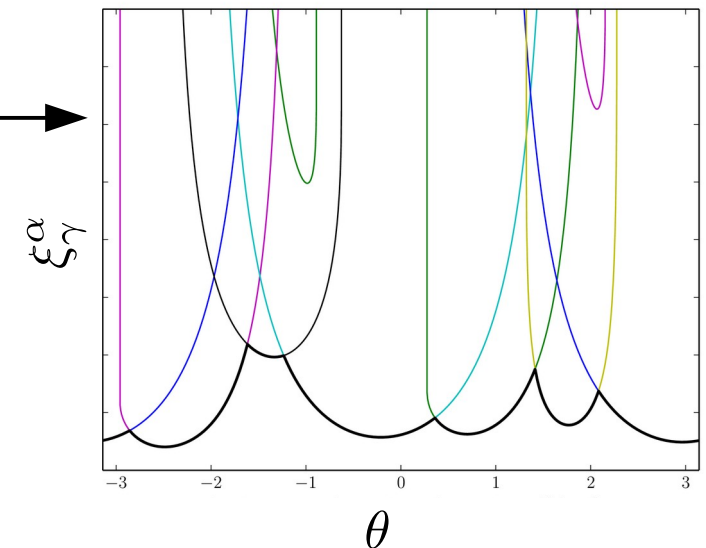
Part I. Transformation of the problem

Instead of discretizing the plane and solving for approximations of Ω_α , we transform the problem as follows



Solving for the transformed problem is equivalent to solve for the overlay of the functions ξ_γ^α of the neighbors Ω_γ of Ω_α .

But, what are the neighbors of Ω_α ?



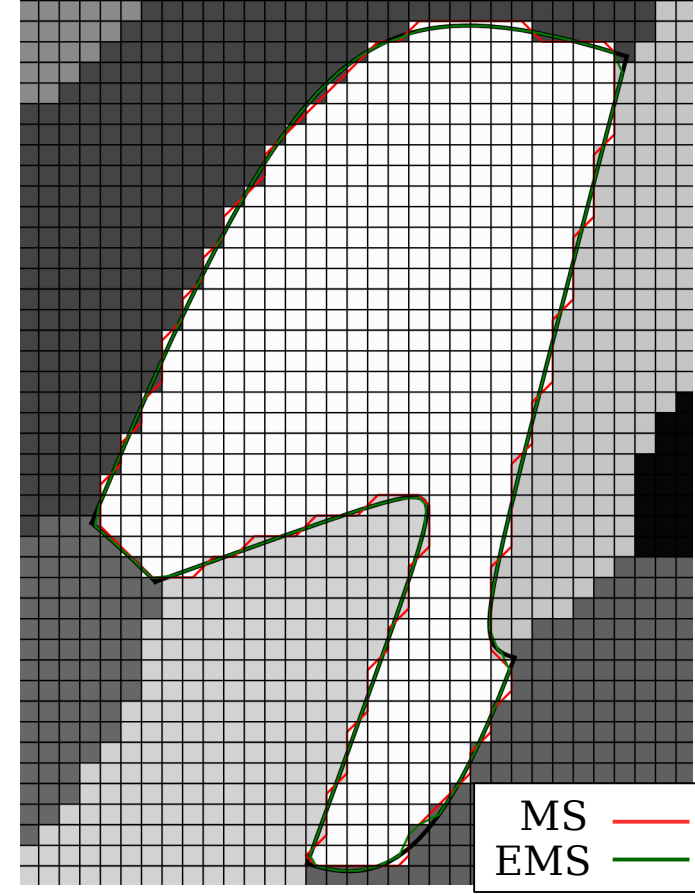
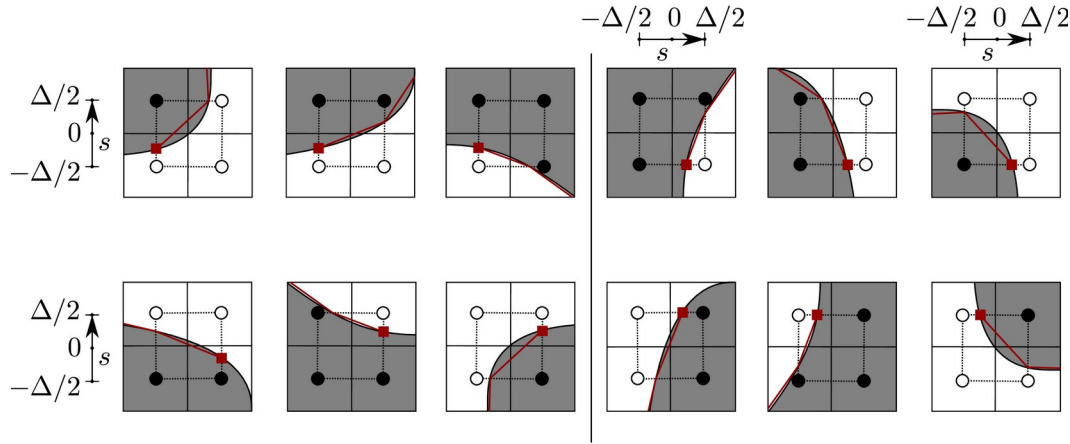
Part I. Enriched Marching Squares (EMS)

Digital
microstructure

Marching square (MS)
algorithms

Approximate
grain boundaries

Using our analytical solution for the grain boundary, we obtain an enriched MS (EMS)



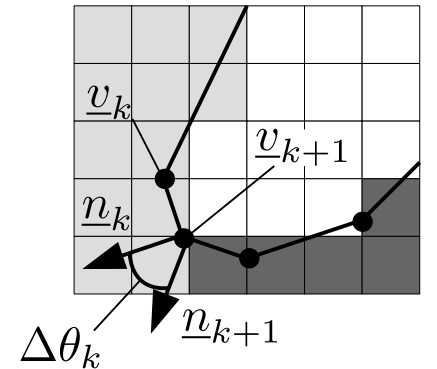
Expressions of Minkowski tensors:

$$\mathcal{W}_0^{r,0} = \frac{1}{r+2} \sum_{k=1}^n \sum_{i=0}^{r+1} \sum_{j=0}^i \binom{r+1}{i} \binom{i}{j} \frac{(-1)^{i-j} L_k}{i+1} \left[\underline{v}_k^{\otimes r+1-j} \odot \underline{v}_{k+1}^{\otimes j} \right] \cdot \underline{n}_k,$$

$$\mathcal{W}_1^{r,s} = \frac{1}{2} \sum_{k=1}^n \sum_{i=0}^r \sum_{j=0}^i \binom{r}{i} \binom{i}{j} \frac{(-1)^{i-j} L_k}{i+1} \underline{v}_k^{\otimes r-j} \odot \underline{v}_{k+1}^{\otimes j} \odot \underline{n}_k^{\otimes s},$$

$$\mathcal{W}_2^{r,s} = \frac{1}{2} \sum_{k=1}^n \sum_{i=0}^s \sum_{j=0}^i \binom{s}{i} \binom{i}{j} \frac{(-1)^{i-j}}{L_k^i} \underline{v}_k^{\otimes i-j} \odot \underline{v}_{k+1}^{\otimes r+j} \odot \underline{n}_k^{\otimes s-i} I_k^{s,i}(\Delta\theta_k)$$

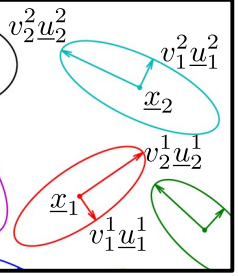
$$L_k = \|\underline{v}_{k+1} - \underline{v}_k\|$$



Part I. Expressions of Minkowski tensors

If the expressions of the common curves and the common points are known, there is no need to approximate the boundaries using an MS algorithm. We have

\underline{x}_α , \underline{u}_1^α and \underline{u}_2^α
are from the MPP.

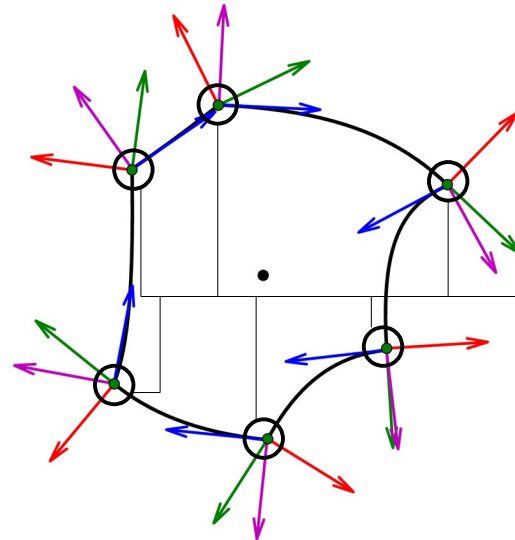


$$\mathcal{W}_0^{r,0} = \sum_{i=0}^r \sum_{j=0}^{r-i} \binom{r}{i+j} \underline{x}_\alpha^{\otimes r-i-j} \odot \underline{u}_1^{\alpha \otimes i} \odot \underline{u}_2^{\alpha \otimes j} I_0^{i,j}$$

$$\mathcal{W}_1^{r,s} = \sum_{i=0}^r \sum_{j=0}^{r-i} \sum_{k=0}^s \binom{r}{i+j} \binom{s}{k} \underline{x}_\alpha^{\otimes r-i-j} \odot \underline{u}_1^{\alpha \otimes s+i-k} \odot \underline{u}_2^{\alpha \otimes j+k} I_1^{i,j,k,s-k}$$

$$\mathcal{W}_2^{r,s} = \sum_{i=0}^r \sum_{j=0}^{r-i} \sum_{k=0}^s \binom{r}{i+j} \binom{s}{k} \underline{x}_\alpha^{\otimes r-i-j} \odot \underline{u}_1^{\alpha \otimes s+i-k} \odot \underline{u}_2^{\alpha \otimes j+k} I_2^{i,j,k,s-k} + \sum_{\underline{y} \in \mathcal{K}_\alpha} \mathcal{D}^{r,s}(\underline{y})$$

where $I_0^{i,j}$ and $I_\nu^{i,j,k,l}$ are scalar coefficients obtained by integrating the functions ξ_γ^α defined for the neighbors Ω_γ of Ω_α .



Effect of
common points

Part II. Periodic Lippmann-Schwinger problems

Periodic elastic Cauchy-Navier problem:

$$\begin{aligned} \boldsymbol{\sigma}(\underline{x}) &= \mathbb{L}(\underline{x}) : \boldsymbol{\varepsilon}(\underline{x}) , & \nabla \cdot \boldsymbol{\sigma}(\underline{x}) &= \underline{0} , & \boldsymbol{\varepsilon}(\underline{x}) &= \{\nabla \underline{u}(\underline{x})\}_{sym} \\ &\text{with } \mathbb{L}(\underline{x} + (n\underline{e}_1 + m\underline{e}_2)L) = \mathbb{L}(\underline{x}) \text{ for all } \underline{x} \in \mathbb{R}^2 \text{ and } n, m \in \mathbb{Z} , \\ &\text{and } \boldsymbol{\sigma}(\underline{x} + (n\underline{e}_1 + m\underline{e}_2)) \cdot \underline{e}_k = \boldsymbol{\sigma}(\underline{x}) \cdot \underline{e}_k , \\ &\text{subjected to } \bar{\boldsymbol{\varepsilon}} = \boldsymbol{\varepsilon}_0 . \end{aligned}$$

Original pb.

where $\bar{\bullet} := \frac{1}{L^2} \int_{\Omega} \bullet(\underline{x}) d\nu_{\underline{x}}$ and $\Omega := [0, L] \times [0, L]$.

Introduce a polarization field $\boldsymbol{\tau}$ with reference \mathbb{L}^0 ,

$$\boldsymbol{\tau}(\underline{x}) := \boldsymbol{\sigma}(\underline{x}) - \mathbb{L}^0 : \boldsymbol{\varepsilon}(\underline{x}) = [\mathbb{L}(\underline{x}) - \mathbb{L}^0] : \boldsymbol{\varepsilon}(\underline{x}) = \Delta \mathbb{L}(\underline{x}) : \boldsymbol{\varepsilon}(\underline{x})$$

leads to a Periodic elastic Lippmann-Schwinger problem:

$$\nabla \cdot \boldsymbol{\tau}(\underline{x}) + \nabla \cdot [\mathbb{L}^0 : \boldsymbol{\varepsilon}(\underline{x})] = \underline{0}$$

Auxiliary pb.

with solution

$$\boldsymbol{\varepsilon}(\underline{x}) = \bar{\boldsymbol{\varepsilon}} - \boldsymbol{\Gamma} * \boldsymbol{\tau}(\underline{x}) = \bar{\boldsymbol{\varepsilon}} - \boldsymbol{\Gamma} * [\Delta \mathbb{L} : \boldsymbol{\varepsilon}(\underline{x})]$$

*Periodic Green
operator for strains.*

where $\boldsymbol{\Gamma} * \boldsymbol{\tau}(\underline{x}) := \int_{\mathbb{R}^2} \boldsymbol{\Gamma}(\underline{x}' - \underline{x}) : \boldsymbol{\tau}(\underline{x}') d\nu_{\underline{x}'}$ is a convolution of $\boldsymbol{\Gamma}(\Delta \underline{x})$.

Part II. Basic approximation scheme

FFT-based iterative scheme:

$$\begin{aligned}\boldsymbol{\tau}(\underline{x}) &\leftarrow \Delta \mathbb{L}(\underline{x}) : \boldsymbol{\varepsilon}_0 \\ {}^0\boldsymbol{\tau}(\underline{x}) &\leftarrow \boldsymbol{\tau}(\underline{x}) \\ \text{while } \|\overline{\nabla \cdot \boldsymbol{\sigma}}\| &> tol : \\ \hat{\hat{\boldsymbol{\varepsilon}}}(\underline{0}) &\leftarrow \mathbf{0} \\ \hat{\hat{\boldsymbol{\varepsilon}}}(\underline{\omega}) &\leftarrow -\hat{\mathbf{\Gamma}}(\underline{\omega}) : \mathcal{FFT}\{\boldsymbol{\tau}(\underline{x})\}(\underline{\omega}) \quad \forall \underline{\omega} \neq \underline{0} \\ \boldsymbol{\tau}(\underline{x}) &\leftarrow {}^0\boldsymbol{\tau}(\underline{x}) + \Delta \mathbb{L}(\underline{x}) : \mathcal{FFT}^{-1}\{\hat{\hat{\boldsymbol{\varepsilon}}}(\underline{\omega})\}(\underline{x})\end{aligned}$$

Pros:

- Easy pre-processing,
- Compatible with anelastic eigenstrain formulations.

Cons:

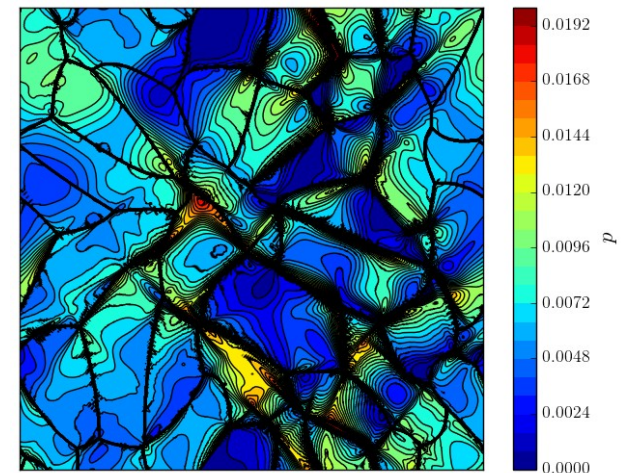
- Uses a lot of memory,
- Post-processing is data intensive,
- No explicit insight about morphology,
- Complexity is $O(n \log n)$ per iteration, for n pixels.

Instead, we want a scheme that

- is especially tailored to polycrystalline microstructures,
- has complexity governed by the number of grains
- carries information about the morphology
- is easy to post-process.

How large need n be?

How many iterations are enough?



Part II. Hashin-Shtrikman variational principle

Consider the Hashin-Shtrikman (HS) functional given by

$$2\mathcal{H}(\boldsymbol{\tau}) := \boldsymbol{\varepsilon}_0 : \mathbb{L}_0 : \boldsymbol{\varepsilon}_0 + \overline{(2\boldsymbol{\tau} : \boldsymbol{\varepsilon}_0 - \boldsymbol{\tau} : (\Delta\mathbb{L})^{-1} : \boldsymbol{\tau} - \boldsymbol{\tau} : (\boldsymbol{\Gamma} * \boldsymbol{\tau}))}$$

- (1) Assuming an equilibrated polarization, i.e. $\boldsymbol{\varepsilon}(\underline{x}) = \bar{\boldsymbol{\varepsilon}} - \boldsymbol{\Gamma} * \boldsymbol{\tau}(\underline{x})$, $\mathcal{H}(\boldsymbol{\tau})$ is stationary at $\boldsymbol{\tau}(\underline{x}) = \Delta\mathbb{L} : \boldsymbol{\varepsilon}(\underline{x})$, irrespectively of \mathbb{L}_0 :

The solution to the Lippmann-Schwinger problem is a stationary point of the HS functional.

- (2) Hashin and Shtrikman (1962) proved that

$$\Delta\mathbb{L}(\underline{x}) \prec 0 \implies \mathcal{H}(\boldsymbol{\tau}) \text{ is strictly convex}$$

Okay. Then, let's consider a piecewise polynomial ansatz

$$\boldsymbol{\tau}^{h_p}(\underline{x}) := \sum_{\alpha} \chi_{\alpha}(\underline{x}) \sum_{k=0}^p \underbrace{\left\langle \boldsymbol{\tau}^{\alpha} \boldsymbol{\partial}^k, (\underline{x} - \underline{x}^{\alpha})^{\otimes k} \right\rangle_k}_{\substack{\text{Symmetric tensor} \\ \text{of order } k+2}}$$

for some p and solve for the minimizer $\{\boldsymbol{\tau}^{\alpha} \boldsymbol{\partial}^k, 0 \leq k \leq p\}$ of $\mathcal{H}(\boldsymbol{\tau}^{h_p})$.

Part II. Implementation & validation

Note that $\mathcal{H}(\tau^{h_p})$ is a quadratic form. Consequently, the minimizer $\{\tau^\alpha \partial^k, 0 \leq k \leq p\}$ is solution of the linear system

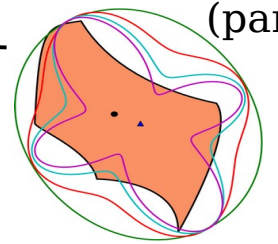
$$\{\bar{\varepsilon}\} = [\Delta \mathbb{M}] \{\tau\} + [\Gamma] \{\tau\}$$

$$\begin{matrix} N \times 1 & N \times N & N \times 1 & N \times N & N \times 1 \end{matrix} \quad \text{where } N = 3n_\alpha \binom{p+2}{2}.$$

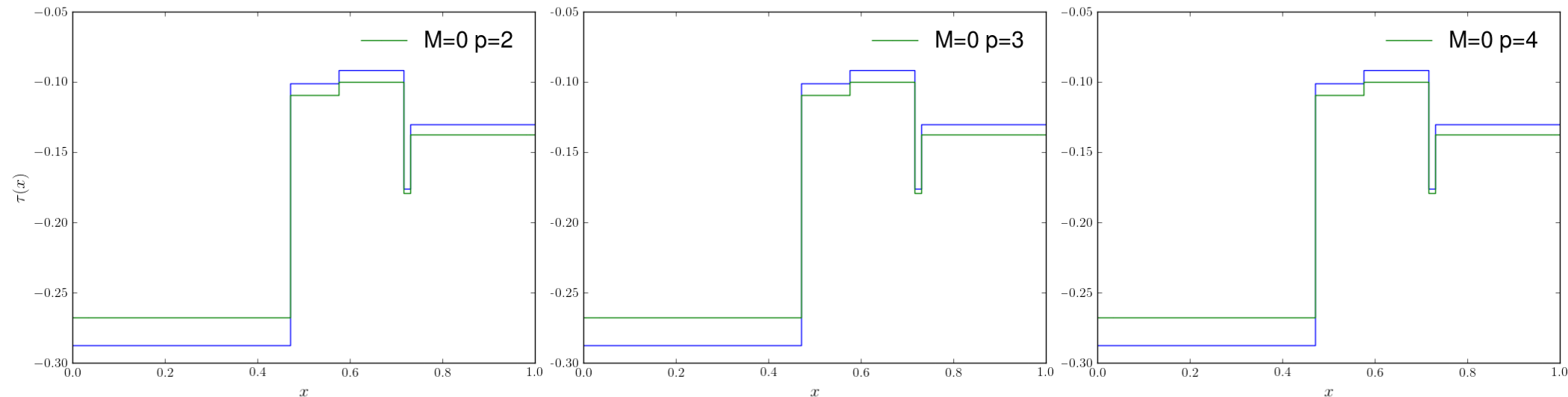
in which $[\Delta \mathbb{M}]_{ij} \propto$ components of $\Delta \mathbb{M}^\alpha \otimes \mathcal{W}_0^{r,0}(\Omega_\alpha)$ with $r \leq 2p$
with $r \leq 2p$ (part I)

$[\Gamma]_{ij} \propto$ components of weighted integrals of $\hat{\Gamma}(\underline{\omega})$
evaluated at $2M$ wave numbers

So that the same $[\Gamma]$ can be used for several realizations of $\Delta \mathbb{L}(x)$.



1D validation:



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Extra-Slide #2 – Transform the problem

Solving for parameterizations of common curves $\mathcal{I}_{\alpha\gamma}$ is difficult. To circumvent this difficulty, we introduce a diffeomorphic transformation.

Let every point of a growing ellipse be given by a time-dependent mapping from a unit circle:

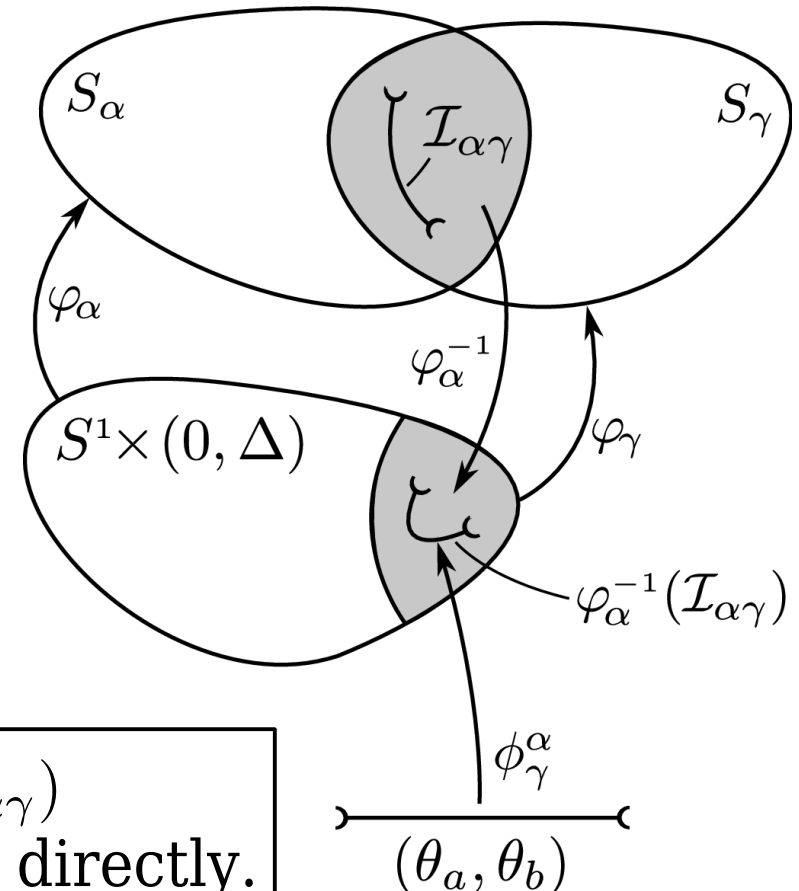
$$\begin{aligned} \varphi_\alpha : S^1 \times (0, \Delta) &\rightarrow S_\alpha \subset \mathbb{R}^2 \\ &: (\underline{x}, t) \mapsto \underline{x}_\alpha + t \mathbf{Z}_\alpha^{-1/2} \cdot \underline{x} \end{aligned}$$

We let the common curves be

$$\mathcal{I}_{\alpha\beta} = \{\underline{y} \in S_\alpha \cap S_\gamma \mid f_\gamma^\alpha(\underline{y}) = 0\}$$

with $f_\gamma^\alpha(\underline{y}) = \tau \circ \varphi_\alpha^{-1}(\underline{y}) - \tau \circ \varphi_\gamma^{-1}(\underline{y})$.

Finding parameterizations ϕ_γ^α of $\varphi_\alpha^{-1}(\mathcal{I}_{\alpha\gamma})$ is much easier than parameterizing $\mathcal{I}_{\alpha\gamma}$ directly.



Extra-slide #1 – Viscoplastic polycrystal model

- Constitutive model: $\dot{\boldsymbol{\sigma}}(t) = \mathbb{L} : [\dot{\boldsymbol{\epsilon}}(t) - \dot{\boldsymbol{\epsilon}}^p(t)]$

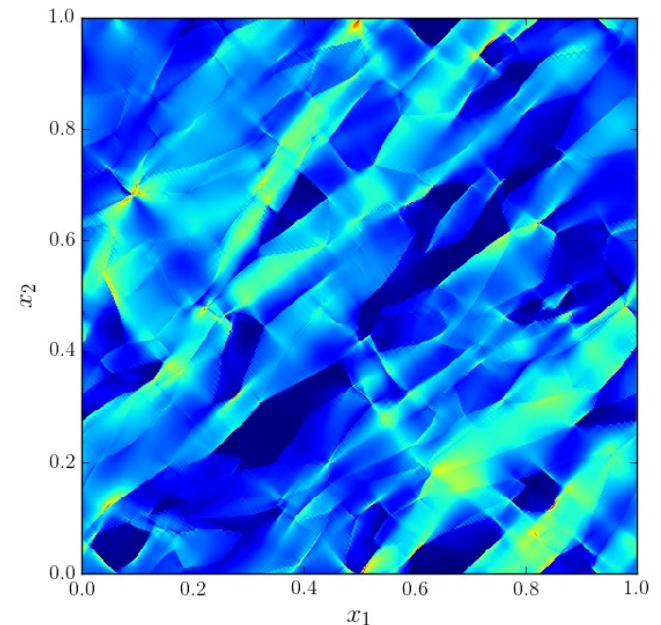
$$\dot{\boldsymbol{\epsilon}}^p = \sum_{\alpha=1}^2 \dot{\gamma}^{(\alpha)} \boldsymbol{\mu}^{(\alpha)} \quad \boldsymbol{\mu}^{(\alpha)} = \underline{m}_{\alpha} \overset{s}{\otimes} \underline{n}_{\alpha} ,$$

$$\dot{\gamma}^{(\alpha)} = \dot{\gamma}_0^{(\alpha)} \left(\frac{|\boldsymbol{\sigma} : \boldsymbol{\mu}^{(\alpha)}|}{\tau^{\alpha}} \right)^{\frac{1}{m}} \text{sgn}(\boldsymbol{\sigma} : \boldsymbol{\mu}^{(\alpha)}) \quad \dot{\tau}^{\alpha} = h \sum_{\beta=1}^2 |\dot{\gamma}^{(\beta)}|$$

- Material properties: 2D isotropic stiffness;

- Sources of randomness:
 - Grain morphology,
 - lattice misorientation

- Quantity of interest: $p = \sum_{\alpha=1}^2 \int_0^t |\dot{\gamma}^{(\alpha)}| d\tau$



Part III. Realization dependent conditional intensity

Markov Marked point processes are an ideal choice of model.